

<b>Notice of References Cited</b>	Application/Control No. 10/803,033	Applicant(s)/Patent Under Reexamination MURAMATSU, TAKAMICHI	
	Examiner Paulos M. Natnael	Art Unit 2622	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,724,101	03-1998	Haskin, Marvin E.	348/441
*	B	US-2003/0206242 A1	11-2003	Choi, Seung Jong	348/441
*	C	US-2003/0001964 A1	01-2003	Masukura et al.	348/441
*	D	US-6,333,762 B1	12-2001	Yoo et al.	348/441
*	E	US-2004/0218094 A1	11-2004	Choi, Seung Jong	348/441
*	F	US-6,052,208 A	04-2000	Lee, Jun Weon	358/468
*	G	US-2003/0174244 A1	09-2003	Nakata, Shinichiro	348/441
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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